ERTIFICATE OF MAIL (37 CFR 1.8(a))

I hereby certify that this correspondence, including listed enclosures, is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on: August 9, 2004.

Laura Lee Mosier

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

*In re* application of:

Art Unit:

2828

JOHN H. HEANUE et al.

Examiner:

Rodriguez, Armando

Application No.

Filed:

09/491,429 January 26, 2000

Date:

August 9, 2004

For: WIDELY TUNABLE LASER

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

This Information Disclosure Statement is hereby submitted in accordance with 37 CFR 1.98 and pursuant to Applicant's continuing duty under 37 CFR 1.56 to bring any information which may be material to patentability of this application to the Examiner's attention.

Applicant submits herewith patents and publications which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 C.F.R. §1.56. While this Statement may be "material" pursuant to 37 C.F.R. §1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is "prior art" for this invention unless specifically designated as such. A listing of patents and publications is shown on enclosed PTO Form 08A and a copy of each patent and publication is also enclosed.

This information disclosure statement is being filed in compliance with 37 CFR 1.97(c)(1) and we state that no item of information contained in the Information Disclosure

Statement submitted herewith, was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing date of this Information Disclosure Statement.

Respectfully submitted,

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## INFORMATION DISCLOSURE TRADES ATEMENT BY APPLICANT

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0.3. Patent and Trademark Office. 0.3. DEPARTMENT OF COMMERCE.					
	Complete if Known				
Application Number	09/491,429				
Filing Date	January 26, 2000				
First Named Inventor	John F. HEANUE				
Art Unit	2828				
Examiner Name Rodriguez, Armando					
Attorney Docket Number	A-68918/ENB (468880-00007)				

U.S. PATENT DOCUMENTS					
Examiner Initials*  Cite No. 1  U.S. Patent Document Number-Kind Code 2 (if known)		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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Application Number 09/491,429			
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First Named Inventor	st Named Inventor John F. HEANUE		
Art Unit	2828		
Examiner Name	xaminer Name Rodriguez, Armando		
A-68918/ENB (468880-00007)			

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Examiner Initials*	Cite No. 1 U.S. Patent Document Number-Kind Code 2 (if known)		Number-Kind Code <sup>2</sup> (if   MM, DD, VVVV		Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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Application Number 09/491,429			
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Art Unit	2828		
Examiner Name	Rodriguez, Armando		
Attorney Docket Number	A-68918/ENB (468880-00007)		

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STATEMENT BY APPLICANT 09/491,429 Application Number January 26, 2000 Filing Date John F. HEANUE First Named Inventor 2828 Art Unit (use as many sheets as necessary) Rodriguez, Armando Examiner Name A-68918/ENB (468880-00007) 5 Attorney Docket Number of Sheet

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NON PATENT LITERATURE DOCUMENTS												
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